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MAR 0 8 2004

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DATE:

March 8, 2004

FILE NO:

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TO:

EXAMINER SYLVIA MACARTHUR

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703-872-9306

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571-272-1438

COMPANY:

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FROM:

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PAGE(S) with cover:

8

ORIGINAL TO

FOLLOW?

[]YES ⊠NO

RESPONSE TO FINAL OFFICE ACTION DATED JANUARY 7, 2004

TITLE:

INTEGRATED SEMICONDUCTOR SUBSTRATE BEVEL

CLEANING APPARATUS AND METHOD

U.S. SERIAL NO.:

(II)/785,815

FILING DATE:

FEB. 16, 2001

INVENTOR:

MOK, ET AL.

EXAMINER:

SYLVIA MACARTHUR

GROUP ART UNIT:

1763

CONFIRMATION NO.:

4.127

CONFIDENTIALITY NOTE

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:

Mok, et al.

Serial No.: 09/785,815

Confirmation No.: 4127

Filed:

February 16, 2001

For.

INTEGRATED SEMICONDUCTOR

SUBSTRATE BEVEL CLEANING APPARATUS AND METHOD

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-145

Dear Sir:

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Examiner:

MAR 0 8 2004

PATENT

Sylvia MacArthur

OFFICIAI

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9306 to the attention of the named Examined on the date below.

3/8/04

Signature

RESPONSE TO FINAL OFFICE ACTION DATED JANUARY 7, 2004

In response to the Final Office Action dated January 7, 2004, having a shortened statutory period for response set to expire on April 7, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/2601.P11/NAN, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Applicants Remarks begin on page 6 of this paper.